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2828

Docket No.: 204552021700
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tetsuyoshi INOUE

Application No.: 09/987,010

Art Unit: 2828

Filed: November 13, 2001

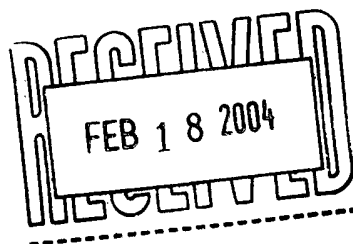
Examiner: Tuan N. Nguyen

For: SEMICONDUCTOR LASER
MANUFACTURING METHOD AND
SEMICONDUCTOR LASER

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AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the final Office Action dated November 5, 2003. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.